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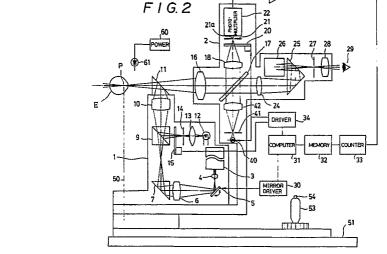
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(54) Ophthalmic measurement apparatus.

The An ophthalmic measurement apparatus is provided in which a laser beam (3a) is converged at a selected point (P) in a measurement zone within an eye and light scattered therefrom is photoelectrically detected via a measurement mask (21) having an aperture (21a) of a prescribed size for ophthalmic measurement. During alignment the measurement zone is scanned at high speed by the laser beam (3a) with the same scanning width (H2) as the scan-

ning width used during measurement. This makes it possible to observe any harmful light rays (A to D) that will actually appear during measurement at those settings and to align the apparatus so that the harmful light rays do not come within the limiting aperture of the measurement mask, thereby enabling measurement to be conducted under optimum conditions.





EUROPEAN SEARCH REPORT

EP 90 30 3588

DOCUMENTS CONSIDERED TO BE RELEVANT					
ategory		h indication, where appropriate, vant passages		levant claim	CLASSIFICATION OF THE APPLICATION (Int. CI.5)
Α	EP-A-0 295 764 (KOWA C * abstract; column 8, lines 3		1		A 61 B 3/10 A 61 B 3/12
Α	US-A-4 019 813 (CORNS) * claim 1; column 4, lines 43		1,6		
A	US-A-4 811 739 (SILVER) * claims 1,4; column 2, lines		1,9		·
					TECHNICAL FIELDS SEARCHED (Int. CI.5) A 61 B
	The present search report has t	peen drawn up for all claims			
	Place of search	Date of completion of	search		Examiner
Berlin 27 September CATEGORY OF CITED DOCUMENTS X: particularly relevant if taken alone Y: particularly relevant if combined with another document of the same catagory A: technological background O: non-written disclosure P: intermediate document T: theory or principle underlying the invention			E: earlier patent document, but published on, or after the filing date D: document cited in the application L: document cited for other reasons 8: member of the same patent family, corresponding document		